

Title (en)

SENSOR CHIP FOR USE IN OPTICAL SPECTROSCOPY

Title (de)

SENSORCHIP ZUR VERWENDUNG IN DER OPTISCHEN SPEKTROSKOPIE

Title (fr)

PUCE DE CAPTEUR DESTINÉE À ÊTRE UTILISÉE POUR UNE SPECTROSCOPIE OPTIQUE

Publication

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Application

EP 07794265 A 20070814

Priority

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Abstract (en)

[origin: WO2009022985A1] A grating-coupled surface plasmon resonance sensor chip having a substrate body comprising at least one fluid channel integrally formed on the surface thereof by imprinting stamp, and a reflective material layer being integrally transferred to at least part of said fluid channel at the same time of the imprinting step.

IPC 8 full level

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CPC (source: EP)

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Citation (search report)

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- See references of WO 2009022985A1

Designated contracting state (EPC)

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